

EXPEDITED PROCEDURE – EXAMINING GROUP 2822

S/N 10/623,788

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Leonard Forbes et al.	Examiner:	Pamela E. Perkins
Serial No.:	10/623,788	Group Art Unit:	2822
Filed:	July 21, 2003	Docket No.:	1303.109US1
Title:	STRAINED SEMICONDUCTOR BY FULL WAFER BONDING		

AMENDMENT & RESPONSE UNDER 37 C.F.R. 1.116

MS RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Final Office Action mailed March 13, 2008, please amend the application as follows: